



Attorney Docket No. 5649-874

PATENT

2813  
Ifw

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Hag-ju Cho  
Serial No.: 09/893,035  
Filed: June 27, 2001

Group Art Unit: 2813  
Examiner: Erik J. Kielin  
Confirmation No.: 3421

For: METHODS OF MANUFACTURING INTEGRATED CIRCUIT DEVICES  
THAT INCLUDE A METAL OXIDE LAYER DISPOSED ON ANOTHER  
LAYER TO PROTECT THE OTHER LAYER FROM DIFFUSION OF  
IMPURITIES AND INTEGRATED CIRCUIT DEVICES  
MANUFACTURED USING SAME

Date: May 21, 2004

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

Applicants provide the present Amendment to address the issues raised in the Official Action mailed February 24, 2004 ("the Action"). Applicants provide the present Amendment pursuant to the rules stated in revised 37 C.F.R. 1.121 that became effective on July 30, 2003.